

Equipment:	Plasma CVD
Manufacturer:	ASM
Model:	Eagle-10 Trident
Vintage:	2007
Wafer Size:	150 mm

<Configuration>

Main Body		
Chamber Number	3 RC-1: SiN/SiON, RC-2: TEOS, RC3: Low-k (Aurora)	
Wafer Transfer Chamber	1	
I/O Load Lock Chamber	2	
Control Cabinet		
Central Control Unit	1	
Operation Portion	1	
Gas Configuration		
Gas Line	N2, SiH4, NH3, N2O, O2, TEOS, C2F6, Ar, He, Aurora 2.7	